INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 18, 2026

IGI Report Number	LG845647990
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	7.81 X 5.47 X 3.58 MM

GRADING RESULTS

Carat Weight	1.52 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	VERY GOOD

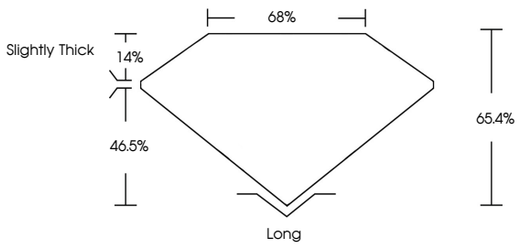
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG845647990

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG845647990
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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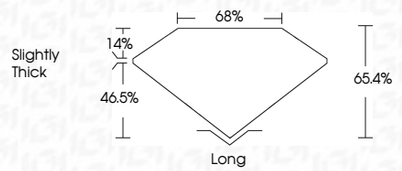
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IGI

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IGI Report No LG845647990
EMERALD CUT
7.81 X 5.47 X 3.58 MM
Carat Weight 1.52 CARAT
Color Grade D
Clarity Grade VVS 2
Cut Grade VERY GOOD
Depth 65.4%
Table 68%
Girdle Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG845647990
Comments:
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Type IIa